



Atty. Docket No. 033082R167

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Taro IKEDA Confirmation No. 8788
Serial No.: 10/635,651 Art Unit: 1792
Filed: August 7, 2003 Examiner: Roberts P. Culbert
For: PLASMA PROCESSING SYSTEM AND PLASMA PROCESSING
METHOD

**RESPONSE AS "SUBMISSION" UNDER 37 C.F.R. 1.114
WITH REQUEST FOR CONTINUED EXAMINATION**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Final Office Action of April 3, 2008, please amend the above-identified application as follows. A Petition for a 3 Month Extension of Time and a Request for Continued Examination (RCE) including the requisite fees are submitted herewith.

Amendments to the claims begin on page 2.

Remarks can begin on page 10.